



Attorney Docket No. 0756-2412

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI

Serial No. 10/021,708

Filed: December 19, 2001

For: HEAT TREATMENT APPARATUS  
AND METHOD OF  
MANUFACTURING A  
SEMICONDUCTOR DEVICE

) Group Art Unit: 3742

) Examiner: Sang Y. Paik

) CERTIFICATE OF MAILING

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) 2007.

) Adrian M. Stamps

RESPONSE

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The Official Action mailed August 13, 2007, has been received and its contents carefully noted. Filed concurrently herewith is a *Request for One Month Extension of Time*, which extends the shortened statutory period for response to December 13, 2007. Accordingly, the Applicant respectfully submits that this response is being timely filed.

The Applicant notes with appreciation the consideration of the Information Disclosure Statements filed on February 25, 2005; August 4, 2005; February 3, 2006; July 28, 2006; and April 19, 2007.

A further Information Disclosure Statement was submitted on October 19, 2007 (received by OIPE on October 22, 2007), and consideration of this Information Disclosure Statement is respectfully requested.

Claims 25-212 are pending in the present application, of which claims 25, 27, 29, 31, 33, 35, 37, 39, 41, 43, 45, 47, 49, 51, 53 and 55 are independent. Claims 57-61, 63-70, 72-79, 81-88, 90-97, 99-106, 108-115, 117-124, 126-133, 135-142, 144-151, 153-160, 162-169, 171-178, 180-187, 189-196 and 198-200 have been withdrawn from